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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Visokay et al. Docket No.: TI-35227
Serial No.: 10/734,708 Art Unit: 2813
Filing Date: 12/11/2003 Examiner: Thanhha S. Pham
Customer No.: 23494 Conf. No.: 2373
Title: Method for Fabricating Transistor Gate Structures and Gate Dielectrics Thereof

CERTIFICATION OF FACSIMILE TRANSMISSION

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NAME OF INVENTOR(S): Visokay et al	
TITLE OF INVENTION: Method for Fabricating . . .	
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